Fabrication of cylindrical resonant microcavities using the confinement provided by partially oxidized AlGaAs/GaAs layers


Abstract
Two different interfaces for optical confinement in GaAs resonators (air/GaAs/air, air/GaAs/AlOx) are compared in cylindrical microstructures with 10 μm diameter. The AlOx is obtained by the lateral oxidation of AlGaAs layers. The spectrum of the resonators is obtained using a tapered fiber system in the wavelength range of 1470nm to 1610nm. The modal separation agrees with our simulation. The quality factor for cylindrical microstructures with air/GaAs/air interface is almost twice the case with AlOx interface. Since it is expected that surface recombination velocity is reduced by a factor of ten for this last case, these structures are shown to be suitable for active resonators.

Key words:
oxidation of AlGaAs, whispering gallery modes, quality factor

Introduction
It is known that GaAs-based active devices are prone to nonradiative surface recombination at unpassivated surfaces. In GaAs cylindrical microresonators, the employment of passivation technique enhances maximal temperature operation and output power. In addition, a reduction of threshold power is observed. A selective oxidation of AlGaAs cladding layers has been proposed by Holoyank and Dallese. The result of the oxidation in the first instance is aluminum oxide (Al2O3) that provides chemical stability to the AlGaAs layer. Aluminum oxide is an insulating material that reduces the refractive index by half, n(AlGaAs)=3 and nAlOx=1.5. These characteristics are used for the confinement of electron and photon in the devices. In this work, we performed the characterization of AlGaAs oxidation process on 500 nm and 300 nm thickness samples. Then two types of cylindrical resonators for optical confinement in GaAs layer were fabricated based on the oxidation results. The difference between them is the interface for GaAs layer: air/GaAs/air and air/GaAs/AlOx. The spectrum of the resonators were obtained using a tapered fiber system in the wavelength range of 1470nm to 1610nm and compared with simulation results.

Results and Discussion
At 380°C the growth rate oxide was of 0.0125 μm/min without GaAs layer degradation for the cylindrical mesas of the samples used. The Fig. 1 shows the depth oxide with time at 380°C on the samples. It is important to note that the length oxide is linear to time and is have not dependence with of the samples thickness. Fig. 2 shows the measure spectrum of microresonator with air/GaAs/air interface in the range from 1470 nm to 1590 nm plotted with a blue line and the spectrum obtained solving the transcendental equation is plotted in bars. The amplitude of the bars was placed to better identify the modes in the measured spectrum. Comparing simulation and experimental results of the microresonator spectrum is observed a better propagation of the TE modes of second radial order. The maximum error between measure and simulation results is 4 nm at 1480 nm. Similarly to previous result, TE modes of second radial order propagates better.

Conclusions
We have fabricated GaAs microresonators using lateral oxidation of AlGaAs layers at 380°C without GaAs layer degradation. Microresonators with air/GaAs/air interface shown better spectrum features than air/GaAs/AlOx interface resulting in better agreement with simulations. The quality factor for cylindrical microstructures with air/GaAs/air interface is almost twice the case with AlOx interface. Since it is expected that surface recombination velocity is reduced by a factor of ten for this last case, these structures are shown to be suitable for active resonators.

Acknowledgement
We would like to acknowledge financial support from FAPESP under Grant (2017/09481-2), FAPESP under the contract 2015/24517-8 and CNPq: 305907/2018-2.